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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

K. Kata et al.

Serial No.: 08/533,207

Group Art Unit: 2503

Filed: September 25, 1995

Examiner: Unknown

For: PROCESS FOR MANUFACTURING SEMICONDUCTOR DEVICE AND  
SEMICONDUCTOR WAFER

Commissioner of Patents and Trademarks  
Washington, D.C. 20231

NOTICE OF CHANGE OF ADDRESS

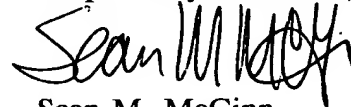
Sir:

Please be advised that the correspondence address of attorneys of record in the  
above-identified application have been changed to:

Whitham, Curtis, Whitham & McGinn  
Reston International Center  
11800 Sunrise Valley Drive, Suite 900  
Reston, Virginia 20191

Please change the records in regard to the above-identified application  
accordingly. The telephone number for the firm remains (703) 391-2510.

Respectfully submitted,



Sean M. McGinn  
Reg. No. 34,386

Whitham, Curtis, Whitham & McGinn  
Intellectual Property Law  
Reston International Center  
11800 Sunrise Valley Dr., Suite 900  
Reston, Virginia 20191  
(703) 391-2510